

Notice of References Cited	Application/Control No. 09/715,935	Applicant(s)/Patent Under Reexamination BI ET AL.	
	Examiner KELLY STOUFFER	Art Unit 1792	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Allen et al. "Abstract: Laser chemical vapor deposition of metals and insulators" J. Vac. Technol., 16(2), Mar/Apr 1979, p 431.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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